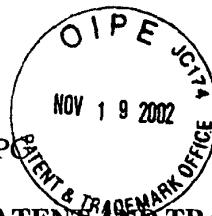


Docket No.: 005918 USA/FPS/MMCS/AP

PATENT/OFFICIAL



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : RECEIVED
SHANMUGASUNDRAM et al. : NOV 20 2002
Serial No. 09/943,955 : Group Art Unit: 2122 Technology Center 2100
Filed: August 31, 2001 : Examiner:
For: FEEDBACK CONTROL OF A CHEMICAL MECHANICAL POLISHING DEVICE
PROVIDING MANIPULATION OF REMOVAL RATE PROFILES

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

This submission does not constitute a representation that a search has been made or that no better art exists and does not constitute an admission or representation that any of the listed documents is material or constitutes prior art. If it should be determined that any of the listed documents does not constitute prior art under the United States law, Applicants reserve the right

Serial No. 09/943,955

to present to the Office the relevant facts and law regarding the appropriate status of such document.

No certification or fee is believed to be required. However, the Commissioner is hereby authorized to charge any additional fees should any be required for this submission, or credit any overpayment to deposit account no. 08-0219.

Respectfully submitted,

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<p style="text-align: center;">INFORMATION DISCLOSURE CITATION IN AN APPLICATION</p> <p style="text-align: center;">(PTO-1449)</p> 		ATTY. DOCKET NO. 005918 USA/FPS/MMCS/APC	SERIAL NO. 09/943,955			
		APPLICANT SHANMUGASUNDRAM et al.				
		FILING DATE August 31, 2001	GROUP 2122			
U.S. PATENT DOCUMENTS						
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	5,655,951	08/12/97	Meikle et al.			09/29/95
	5,823,854	10/20/98	Chen			05/28/96
	5,859,975	01/12/99	Brewer et al.			08/09/96
	6,389,491	05/14/02	Jacobson et al.			03/23/99
						RECEIVED
						NOV 20 2002
						Technology Center 2100
FOREIGN PATENT DOCUMENTS						
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation
						Yes
	2 347 885 A	09/20/00	GB			X
	WO 01/15865 A1	03/08/01	WO			X
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)						
	July 23, 2002. Communication Pursuant to Article 96(2) EPC for European Patent Application No. 00 115 577.9.					
	October 15, 2002. International Search Report prepared by the European Patent Office for PCT/US02/19062.					
EXAMINER	DATE CONSIDERED					

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.